

<b>Notice of References Cited</b>	Application/Control No.	Applicant(s)/Patent Under Reexamination	
	10/550,964	ZHANG ET AL.	
	Examiner Nathan Mitchell	Art Unit 2609	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0005883 A1	06-2001	Wray et al.	713/151
*	B	US-2002/0136226 A1	09-2002	Christoffel et al.	370/401
*	C	US-2003/0112977 A1	06-2003	Ray et al.	380/270
*	D	US-2003/0115460 A1	06-2003	Arai, Shunji	713/168
*	E	US-2004/0181663 A1	09-2004	Pienimaki et al.	713/155
*	F	US-2005/0059396 A1	03-2005	Chuah et al.	455/435.1
*	G	US-2005/0113070 A1	05-2005	Okabe, Toshiya	455/411
*	H	US-2005/0177733 A1	08-2005	Stadelmann et al.	713/185
*	I	US-2002/0046179 A1	04-2002	Kokudo, Junichi	705/51
J	US-				
K	US-				
L	US-				
M	US-				

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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